



Docket No.: 063979-0032

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Response Under 37 CFR 1.116 - Expedited Procedure
Yoshiaki HASEGAWA, et al.	:	Customer Number: 20277
Application No.: 10/643,944	:	Confirmation Number: 3843
Filed: August 20, 2003	:	Group Art Unit: 2828
	:	Examiner: Tod Thomas VAN ROY
For: SEMICONDUCTOR LASER AND PROCESS FOR MANUFACTURING THE SAME	:	

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 27, 2006, having a three-month shortened statutory period for response set to expire January 27, 2007, please amend the above-identified application as follows:

Entered
01/06/07
FAC
[Signature]